

DIN EN ISO 14880-2:2007-03 (E)

Optics and photonics - Microlens arrays - Part 2: Test methods for wavefront aberrations (ISO 14880-2:2006)

| Contents | | Page |
|---|--|-------------|
| Foreword | | 3 |
| Introduction | | 4 |
| 1 Scope | | 5 |
| 2 Normative references | | 5 |
| 3 Terms and definitions | | 5 |
| 4 Symbols and abbreviated terms | | 5 |
| 5 Apparatus | | 6 |
| 5.1 General | | 6 |
| 5.2 Standard optical radiation source | | 6 |
| 5.3 Standard lens | | 6 |
| 5.4 Collimator | | 6 |
| 5.5 Beam reduction optical system | | 6 |
| 5.6 Aperture stop | | 7 |
| 6 Test principle | | 7 |
| 7 Measurement arrangement | | 7 |
| 7.1 Measurement arrangement for single microlenses | | 7 |
| 7.2 Measurement arrangement for microlens arrays | | 7 |
| 7.3 Geometrical alignment of the sample | | 8 |
| 7.4 Preparation | | 8 |
| 8 Procedure | | 8 |
| 9 Evaluation | | 8 |
| 10 Accuracy | | 8 |
| 11 Test report | | 9 |
| Annex A (normative) Measurement requirements for test methods for microlenses | | 10 |
| Annex B (normative) Microlens test Methods 1 and 2 using Mach-Zehnder interferometer systems .. | | 12 |
| Annex C (normative) Microlens test Methods 3 and 4 using a lateral shearing interferometer system | | 17 |
| Annex D (normative) Microlens test Method 5 using a Shack-Hartmann sensor system | | 22 |
| Annex E (normative) Microlens array test Method 1 using a Twyman-Green interferometer system .. | | 24 |
| Annex F (normative) Measurement of uniformity of microlens array determined by test Method 2 | | 26 |
| Bibliography | | 29 |